



TSUCHIYA et al.

Application Number: 10/750,882

Filed: January 5, 2004

For: METHOD FOR PRODUCING NANOPARTICLE LAYER HAVING UNIFORM EASY AXIS OF MAGNETIZATION, MAGNETIC RECORDING MEDIUM HAVING SUCH LAYER, ITS PRODUCTION METHOD, AND ITS PRODUCTION APPARATUS

Attorney Docket No. HITA.0482

**Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

Art Unit 1773

Examiner Holly C. Rickman

RESPONSE AND AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

This is in response to the Office Action mailed on March 8, 2006, the period of response to which is set to expire on July 8, 2006, with the payment of the appropriate government extension fee for one month. Please amend the above-referenced application as follows:

06/28/2006 SZEWDIE1 00000146 10750882
02 FC:1202

50.00 DP